

Application/Control No.	Applicant(s)/Patent under Reexamination	
10/708,327	CHIU ET AL.	
Examiner	Art Unit	
Jeffrey S. Zweizig	2816	

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SEARCHED						
Class	Subclass	Date	Examiner			
326	80	3/3/2005	JZ			
V	81					
327	318					
	319					
V	333	V	1			
vpdate	above	5/24/05	JZ			

INTERFERENCE SEARCHED					
Class	Subclass	Date	Examiner		
327	333	5/24/05	IZ		

SEARCH NOTES (INCLUDING SEARCH STRATEGY)				
	DATE	EXMR		
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